



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q55902

Makoto KASHIWAYA, et al.

Allowed: January 26, 2004

Appln. No.: 09/534,207 ✓

Group Art Unit: 1765

Confirmation No.: 2981

Examiner: DEO, DUY VU NGUYEN

Filed: March 24, 2000

For: CARBON LAYER FORMING METHOD

**REQUEST FOR ACKNOWLEDGEMENT OF RECEIPT
OF PRIORITY DOCUMENT**

MAIL STOP ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Applicants respectfully request acknowledgement of the priority document (JP 11-083913 March 26, 1999), which was filed March 24, 2000, in the above identified application.

Please note that the priority document was filed together with the application on March 24, 2000. Proof of Applicant's submission, including the face page of the priority document, application transmittal letter, and the date-stamped filing receipt, are enclosed for the Examiner's convenience.

Respectfully submitted,

Raja Saliba

Registration No. 43,078

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WASHINGTON OFFICE



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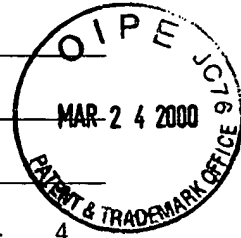
PATENT TRADEMARK OFFICE

Date: February 19, 2004

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REQUEST OF EARLY NOTIFICATION OF SERIAL NUMBER

Inventor: M. KASHIWAYA & J. NAKADA
Title: CARBON LAYER FORMING METHOD
Atty Doc #: Q55902 CLIENT: ION PATENT
Filing Date: 03/24/00 # Pages Spec/Abst: 33/1 # Claims: 4
Dwg. Sheets: 1 Decl NO Prelim Amdt NO
IDS/Prior Art: NO Pr Doc: YES (1) Asgmt: NO Fee: \$690.00
NO Check attached NO Charge to Deposit # 19-4880 Atty/Secy: DM/clf
SERIAL NO: _____





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March 24, 2000

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BOX: PATENT APPLICATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Re: Application of Makoto KASHIWAYA and Junji NAKADA
CARBON LAYER FORMING METHOD
Our Reference: Q55902

Dear Sir:

Attached hereto is the application identified above including the specification, claims, one (1) sheet of drawings and one (1) priority document. The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total Claims	4 - 20 =	0 x \$18 =	\$ 000.00
Independent Claims	1 - 3 =	0 x \$78 =	\$ 000.00
Base Filing Fee	(\$690.00)		\$ 690.00
Multiple Dep. Claim Fee	(\$260.00)		\$ 000.00
TOTAL FILING FEE			\$ 690.00

Priority is claimed from:

Japanese Patent Application

11-083913

Filing Date

March 26, 1999

Respectfully submitted,
SUGHRUE, MION, ZINN, MACPEAK & SEAS
Attorneys for Applicant(s)

By: Darryl Mexic
Darryl Mexic
Reg. No. 23,063

DM:clf

MAR 24 2000

日 本 国 特 許 庁

PATENT OFFICE
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

出 願 年 月 日
Date of Application:

1999年 3月26日

出 願 番 号
Application Number:

平成11年特許願第083913号

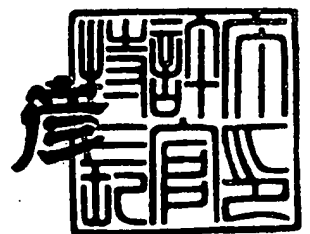
出 願 人
Applicant(s):

富士写真フイルム株式会社

1999年 9月24日

特 許 庁 長 官
Commissioner,
Patent Office

近 藤 隆 彦



出証番号 出証特平11-3065059